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Docket No.: 2328-059

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : : **EXPEDITED PROCEDURE**  
Rajinder DHTNDSA, et al. : : **Response under 37 CFR 1.116**  
U.S. Patent Application No. 10/032,279 : : **Confirmation No. 4056**  
Filed: December 31, 2001 : : **Group Art Unit: 1763**  
: : **Examiner: ANNA M. CROWELL**

For: **PLASMA PROCESSOR IN PLASMA CONFINEMENT REGION WITHIN A  
VACUUM CHAMBER**

SUPPLEMENTAL AMENDMENT UNDER RULE 116

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

December 29, 2004

Sir:

This paper is submitted supplementary to the Amendment under Rule 116 filed on November 18, 2004 and further in reply to the Office Action mailed October 15, 2004, which was made Final. Applicants respectfully request that the following amendments **as to form** be entered to place this application in condition for allowance.

CERTIFICATION OF FACSIMILE TRANSMISSION  
I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMI-  
LE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE  
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ALICE WEAVER  
TYPE OR PRINT NAME OF PERSON SIGNING CERTIFICATION  
Alice Weaver 12-29-04  
SIGNATURE DATE  
703/872-9306  
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